Amendments to the Claims

This list of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

- 1. (Previously presented) A semiconductor isolation structure comprising:
 - a substrate, the substrate comprising a surface;
 - a first device and a second device formed within the substrate;
- an isolation region formed within the substrate between the first device and the second device, the isolation region comprising:
 - a single deep region which extends into the substrate, the deep region comprising a deep region cross-sectional area, the deep region abutting only the substrate and a single shallow region;
 - [a] the single shallow region [which extends] extending to the surface of the substrate, the shallow region comprising:
 - a protective outer wall adjacent to the substrate and extending to the surface of the substrate;
 - an inner sealing wall located exclusively within the shallow region and adjacent to the protective outer wall, extending to the surface of the substrate[:]; and
 - the shallow region having a shallow region cross-sectional area;
 wherein the deep region cross-sectional area is greater than the shallow
 region cross-sectional area, the deep region abutting only a single shallow region.
- 2. (Original) The semiconductor isolation structure as recited in claim 1, wherein the isolation region comprises an oxide.
- 3. (canceled)

- 4. (Previously presented) The semiconductor isolation structure as recited in claim 1, wherein the protective outer wall comprises a layer of oxide.
- 5. (Previously presented) A semiconductor isolation structure comprising:
 - a substrate, the substrate comprising a surface;
 - a first device and a second device formed within the substrate;
- an isolation region formed within the substrate between the first device and the second device, the isolation region comprising:
 - a single deep region which extends into the substrate, the deep region comprising an oxide, the deep region abutting only the substrate and a single shallow region;
 - [a] the single shallow region [which extends] extending to the surface of the substrate, the shallow region comprising:
 - a protective outer wall adjacent to the substrate and extending to the surface of the substrate,
 - an inner sealing wall located exclusively within the shallow region and adjacent to the protective outer wall extending to the surface of the substrate.
- 6. (Previously presented) The semiconductor isolation structure of claim 5, in which the protective outer wall comprises an oxide and the inner sealing wall comprises a nitride.

Claims 7-9 (canceled)